

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q81007

Yasushi OKUBO, et al.

Appln. No.: 10/820,785

Group Art Unit: 1756

Confirmation No.: 8719

Examiner: Stephen D. ROSASCO

Filed: April 9, 2004

For: METHOD OF MANUFACTURING A PHOTOMASK, AND PHOTOMASK BLANK

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 22, 2007, please amend the above-identified application as follows on the accompanying pages.

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